

COPY

PATENT

AMENDMENTS TO THE SPECIFICATION

Please amend the title in all instances as follows:

METHOD OF FORMING AN ETCHED METAL TRACE WITH REDUCED RF IMPEDANCE  
RESULTING FROM THE SKIN EFFECT

Please Insert the following paragraph before the first paragraph on page 1:

This is a divisional application of Application Serial No. 10/219,212 filed on  
August 15, 2002.

Divisional of 10/219,212  
PRELIMINARY AMENDMENT

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Attorney Docket No. 100-18310  
(P05271-D01)